

2026 The 9th International Symposium on Advanced Science and Technology of Silicon and Related materials

Oct. 6 (Tues)	Oct. 7 (Wed)	Oct. 8 (Thurs)	Oct. 9 (Fri)
	Morning9:30-12:00105 min Session-B1 (Power)Chair: Yasuhisa Sano B-1 Julie Widiez (CEA-Leti, France)30 min B-2 Vladimir Odnoblyudov (Gromis, Inc., USA)30 min Coffee Break10:30-11:00 60 min11:00-12:00 Session-B2 (Power)Chair: Yasuhisa Sano B-3 Tomoyuki Uchida (Toray Research Center, Japan)30 min B-4 Yongzhao Yao (Mie University, Japan)30 min	Morning8:45-12:00105 min Plenary-2Chair: Ryo Yokogawa Pl-2 Shogo Mochizuki (IBM, USA)45 min Session-C1 (LSTC)Chair: Ryo Yokogawa C-1 Toshiro Hiramoto (The University of Tokyo, Japan)30 min C-2 Koji Usuda (Meiji Univ. Japan)30 min Coffee Break10:30-11:00 60 min11:00-12:00 Session-C2 (LSTC)Chair: Ryo Yokogawa C-3 Akinobu Teramoto (Hiroshima Univ. Japan)30 min C-4 Koji Matsumoto (SUMCO, Japan)30 min	Morning9:30-12:0060 min Session-A2 (SI)Chair: Takayoshi Shimura A-3 Hanfei Yan (Brookhaven National Laboratory, USA)30 min A-4 Nobuya Nakazaki (Sony Semiconductor Solutions, Japan)30 min Coffee Break10:30-11:00 60 min11:00-12:00 Session-D1 (Info)Chair: Rami Konagaya D-1 Yuta Aoki (Mallantis, Japan)30 min D-2 Shota Seki (Aixtal, Japan)30 min
Registration open13:30	Lunch Break12:00-13:30 Afternoon13:30-18:35120 min Session-B3 (Power)Chair: HidekazuTsuchida B-5 Can Zhu (SICC, China)30 min B-6 Slobodan Mitic (PVA TePla, Germany)30 min B-7 Michael Dudley (Stony Brook University, USA)30 min B-8 Kazuhisa Torigoe (SUMCO, Japan)30 min	Photo Session12:00 Lunch Break12:00-13:30 Optional tour13:30-	Lunch Break12:00-13:30 Afternoon13:30-14:3060 min Session-D2 (Info)Chair: Kentaro Kutsukake D-3 Andrey Smirnov (STR Belgrade, Serbia)30 min D-4 Shigetaka Tomiya(Nara Institute of Science and Technology, Japan)30 min
	Coffee Break16:30-16:50 60 min (2.5min/paper)16:50-17:45 Session-P1 (Short Presentation for Poster)Chair: Haruo Sudo P-1 Iori Takeda (Okayama Pref. Univ., Japan) P-2 Eiji Kamiyama (GWJ/Okayama Pref. Univ., Japan) P-3 Takao Goto (The University of Osaka, Japan) P-4 Takuya Kusunoki (Okayama Pref. Univ./GWJ, Japan) P-5 ShomaTsukada (Shinsyu University, Japan) P-6 Takuma Murase (Shinsyu University, Japan) P-7 Rei Saito (Shinsyu University, Japan) P-8 Yuta Fujimoto (Univ. of Yamanashi, Japan) P-9 Koji Ozawa (Okayama Pref. Univ., Japan) P-10 Yuta Goto (NIMS, Japan) P-11 Yukito Soejima (Meiji University, Japan) P-12 Shogen Matsumoto (Crystal IS, Inc., USA) P-13 Clara Rebanal Castro (Universidad Autónoma de Madrid, Spain) P-14 Yusuke Morita (The University of Osaka, Japan) P-15 Yutaka Maki (Univ. of Yamanashi, Japan) P-16 Tarou Iizuka (Kogakuin Univ, Japan) P-17 Kotaro Tetsu (Ibaraki University, Japan) P-18 Rogie Maghinay Madula (Nara Institute of Science and Technology, Japan) P-19 Hibiki Bekku (Okayama Pref. Univ., Japan) P-20 Shuto Araki (ROHM Co. Ltd, Japan) P-21 Ryoken Tsuji (Okayama Pref. Univ., Japan) P-22 Kentaro Kutsukake (Nagoya University, Japan)	Coffee Break16:30-16:50 60 min (2.5min/paper)16:50-16:50 Session-P2 (Short Presentation for Poster)Chair: Ryota Suewaka P-23 Michio Tajima (Institute of Space and Astronautical Science/JAXA, Japan) P-24 Rahmat Hadi Saputro (AIST, Japan) P-25 Yuhui Huang (Waseda University, Japan) P-26 Jiayi Liang (Waseda University, Japan) P-27 Kazuhiko Omote (Rigaku Corporation, Japan) P-28 Yuto Hashikura (The Univ. of Osaka, Japan) P-29 Yuta Goto (NIMS, Japan) P-30 Hironori Banba (Kyushu Institute of Technology/GWJ, Japan) P-31 Kohaku Abe (Toyota Tech. Inst., Japan) P-32 Zhi Zhong Chen (Toyota Tech. Inst., Japan) P-33 Kousuke Shimano (Ibaraki University, Japan) P-34 Takahiro Kawamura (Mie University, Japan) P-35 Shotaro Gonda (Shinsyu University, Japan) P-36 Haruki Ishikawa (Kogakuin Univ, Japan) P-37 Koji Sueoka (Okayama Pref. Univ., Japan) P-38 Atsushi Takahashi (Toyota Tech. Inst., Japan) P-39 Yuta Ito (Meiji University, Japan) P-40 Tatsuro Maeda (AIST, Japan) P-41 Mahiro Tanaka (Nagoya University, Japan) P-42 Hiromu Kudo (Meiji University, Japan) P-43 Shotaro Matsumura (S-Surface Technologies Co. Ltd, Japan) P-44 Ichiro Hayamizu (Toyota Tech. Inst., Japan) P-45 Taisei Matsushita (Toyama Pref. Univ., Japan)	Benquet16:30-20:30
105 min17:45-18:30Session-P1 (Poster Presentation)Posters P-1 ~P-22	105 min16:50-18:35Session-P2 (Poster Presentation)Posters P-23 ~P-45		Closing Remarks14:30-14:45